

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hidemasa KAI**

Art Unit: **1792**

Application Number: **10/626,675**

Examiner: **Ram N. Kackar**

Filed: **July 25, 2003**

Confirmation Number: **1831**

For: **EPITAXIAL WAFER PRODUCTION APPARATUS AND SUSCEPTOR
STRUCTURE**

Attorney Docket Number: **030901**
Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCESSING REQUESTED

Mail Stop: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 22, 2009

Sir:

This paper is filed (along with a petition for a one-month extension of time) in response to the Office Action dated August 20, 2009. The PTO was closed on December 20 (Sunday) and 21 (USPTO closed due to inclement weather).

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.